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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2823  
Examiner: George R. Fourson III

In Re PATENT APPLICATION OF:

Applicant(s) : Yasuo TANAKA )

Serial No. : 09/660,484 )

Filed : September 12, 2000 )

METHOD OF MANUFACTURING  
SEMICONDUCTOR DEVICE )

Attorney Ref. : OKI 262 )

**RESPONSE TO  
OFFICE ACTION**

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December 9, 2004

**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

This paper is submitted in response to the Office Action dated September 9, 2004.

For at least the reasons set forth in the Remarks that follow, it is respectfully requested that the rejections of the pending claims be reconsidered and withdrawn.

**FEE ENCLOSED:\$**  
Please charge any further  
fee to our Deposit Account  
No. 18-0002